MAIKP131US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re **PATENT** application of:

Applicant:

Huang et al.

Serial No.:

10/814,570

For:

PROCESS FOR ETCHING A SUBSTRATE (as translated)

Filing Date:

March 31, 2004

Examiner:

(presently unknown)

Art Unit:

(presently unknown)

PRELIMINARY AMENDMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following remarks.